



Attorney's Docket No.: 3558P020D2

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

James M. Cleeves et al.

U.S. Serial No: 10/800,078

Examiner: Ngo, Ngan V.

Filed: March 12, 2004

Art Unit: 2814

For: INTEGRATED CIRCUIT
FEATURE LAYOUT FOR IMPROVED
CHEMICAL MECHANICAL POLISHING)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Final Office Action mailed February 8, 2005.

Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks in the Request for Continued Examination (RCE) filed concurrently herewith.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP _____
COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450
U.S. Patent and Trademark Office, Washington, D.C. 20231 on May 9, 2005.

Date of Deposit

Teresa Mattox

Name of Person Mailing Correspondence

Teresa Mattox

Signature

May 9, 2005

Date